Application/Control No. Applicant(s)/Patent Under Reexamination 10/023,438 EIDEN ET AL. Notice of References Cited Examiner Art Unit Page 1 of 1 David Q Nguyen 2681 **U.S. PATENT DOCUMENTS** Document Number Date Name Classification Country Code-Number-Kind Code MM-YYYY Α US-2003/0069004 04-2003 Hamynen et al. 455/412 В US-2002/0078157 06-2002 Matsumoto, Shigeki 709/206 С US-D US-US-Ε F US-US-G US-Н US-J US-Κ US-L US-US-М **FOREIGN PATENT DOCUMENTS** Document Number Date Country Name Classification Country Code-Number-Kind Code MM-YYYY Ν 0 Ρ Q R S Т **NON-PATENT DOCUMENTS**

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